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**TRANSMITTAL  
FORM**

(to be used for all correspondence after initial filing)

Application Number	10/603,389
Filing Date	06/25/03
First Named Inventor	Sethuraman Jayashankar
Art Unit	2818
Examiner Name	Thao P. Le
Attorney Docket Number	SEAG 63336

Total Number of Pages in This Submission

**ENCLOSURES (Check all that apply)**

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| <input type="checkbox"/> Fee Transmittal Form<br><input type="checkbox"/> Fee Attached<br><input type="checkbox"/> Amendment/Reply<br><input type="checkbox"/> After Final<br><input type="checkbox"/> Affidavits/declaration(s)<br><input type="checkbox"/> Extension of Time Request<br><input type="checkbox"/> Express Abandonment Request<br><input type="checkbox"/> Information Disclosure Statement<br><input type="checkbox"/> Certified Copy of Priority Document(s)<br><input type="checkbox"/> Response to Missing Parts/<br>Incomplete Application<br><input type="checkbox"/> Response to Missing Parts<br>under 37 CFR 1.52 or 1.53 | <input type="checkbox"/> Drawing(s)<br><input type="checkbox"/> Licensing-related Papers<br><input type="checkbox"/> Petition<br><input type="checkbox"/> Petition to Convert to a<br>Provisional Application<br><input type="checkbox"/> Power of Attorney, Revocation<br>Change of Correspondence Address<br><input type="checkbox"/> Terminal Disclaimer<br><input type="checkbox"/> Request for Refund<br><input type="checkbox"/> CD, Number of CD(s) _____ | <input type="checkbox"/> After Allowance communication<br>to Technology Center (TC)<br><input type="checkbox"/> Appeal Communication to Board<br>of Appeals and Interferences<br><input type="checkbox"/> Appeal Communication to TC<br>(Appeal Notice, Brief, Reply Brief)<br><input type="checkbox"/> Proprietary Information<br><input type="checkbox"/> Status Letter<br><input checked="" type="checkbox"/> Other Enclosure(s) (please<br>Identify below):<br>- Response to Restriction Requirement<br>- return postcard |
|--|--|---|

Remarks

**SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT**

Firm or Individual name	Robert P. Lenart Pietragallo, Bosick & Gordon
Signature	<i>Robert P. Lenart</i>
Date	04/23/2004

**CERTIFICATE OF TRANSMISSION/MAILING**

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below.

Typed or printed name	Robert P. Lenart		
Signature	<i>Robert P. Lenart</i>	Date	04/23/2004

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/603,389 Confirmation No. 3058  
Applicant : Sethuraman Jayashankar  
Filed : June 25, 2003  
Title : METHOD OF DETECTING CHEMICAL MECHANICAL  
POLISHING ENDPOINTS IN THIN FILM HEAD  
PROCESSES  
Art Unit : 2818  
Examiner : Thao P. Le  
Docket No. : SEAG 63336

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

April 23, 2004

**RESPONSE TO RESTRICTION REQUIREMENT**

SIR:

In response to the Restriction Requirement dated April 20, 2004, Applicants elect without traverse to prosecute the claims in Group I, claims 1-14 drawn to a method of chemical mechanical polishing a wafer.

In the event that any outstanding matters remain in connection with this matter, the Examiner is invited to telephone the undersigned in order to expedite the handling of such matters.

Respectfully submitted,

*Robert P. Lenart*

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